

Properties of Irradiated CdTe Detectors

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Cadmium Telluride (CdTe) is a compound semiconductor with a large atomic number. It has a large photon absorption cross section in comparison with the silicon and germanium and due to its large bandgap width it can be operated at room temperature. These properties predetermine CdTe to wide range of applications: from medical and industrial radiographic imaging to space sciences. In this paper, several characteristics of a commercially available CdTe sensors from two manufacturers were compared. The CdTe sensor samples were subject of measurement of their basic electronic characteristics at different temperatures ranging from -40 to +40°C. Additionally, the effects of ^{60}Co gamma irradiation up to a dose of 100 kGy were studied at room temperature.

*The 23rd International Workshop on Vertex Detectors,
15-19 September 2014
Macha Lake, The Czech Republic*

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1. Introduction

Cadmium Telluride (CdTe) is due to a high atomic number ($Z(\text{Cd}) = 48$ and $Z(\text{Te}) = 52$) a favorable material for the production of sensors of X-ray radiation. Furthermore, CdTe detectors can be operated at room temperature.

Due to its mechanical and physical properties the CdTe is widely used material. Therefore, in the recent years the CdTe sensors were subject of study of their basic characteristics, effects of different types of radiation (gamma, electrons, positrons, protons, neutrons) [1, 2, 3, 4, 5, 6] etc. However the manufacturing technologies of CdTe crystals are continuously improving, with results in larger detectors with more uniform response and better radiation hardness.

In this work, we present a study of the basic electrical characteristics of the currently (May 2014) commercially available CdTe sensors at a temperature range of $(-40, +40)^\circ\text{C}$ and the effects of gamma radiation at room temperature by the means of I-V measurement to assess their potential performance in modern medical imaging.

2. Characteristics of CdTe detectors

CdTe detectors are generally fabricated by using metal-semiconductor-metal (MSM) structures. There are two main sensor types: Ohmic type and Schottky type.

These two types of sensors differ only by the contact electrodes. Ohmic contacts are formed by metals with a high work function, such as gold or platinum. Ohmic electrodes are placed on both sides of the Ohmic sensor type. Schottky sensor type uses an ohmic contact on one side of the sensor (cathode) and a blocking contact implemented with an In/Ti on the other side (anode) [7]. The platinum contact is fabricated by electroless plating, while the indium and titanium contact are formed by vacuum evaporation [7]. A structure of both types of sensors is schematically shown in Fig.1.

Both, Ohmic and Schottky type sensors have been studied in this work. One Ohmic type sensor (size: $4.83 \times 4.83 \times 1 \text{ mm}^3$) was purchased from manufacturer #1, and two samples, one Ohmic and one Schottky type sensors (size: $4 \times 4 \times 1 \text{ mm}^3$), were purchased from manufacturer #2.

Manufacturers recommend the optimum bias voltage to obtain the best energy spectrum. For the Ohmic type sensors it is 70 V and for the Schottky type sensors it is 700 V.

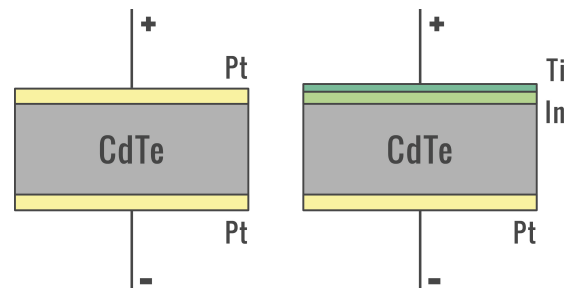


Figure 1: The structure of CdTe Ohmic (left) and Schottky (right) type detectors [7].

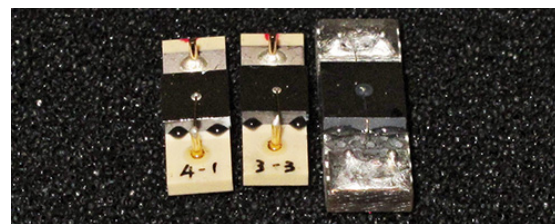


Figure 2: Tested samples: Schottky type sensor from manufacturer #2 (left), Ohmic type sensors from manufacturer #2 (center) and from manufacturer #1 (right).

Fig.3 shows the I-V characteristics of the Ohmic (left) and the Schottky (right) sensors measured in a light-tight box at room temperature. The dark current of the Schottky type sensor is very small in comparison with the Ohmic type sensor. At 700 V, it is only 10 nA, while for Ohmic type it is already 40 nA at 70 V. The difference of the leakage current between these sensor types is due to the fact that Schottky type sensors have a high resistance surface layer with almost constant negative charge density (the blocking layer or Schottky barrier) on the anode side. Therefore Schottky type sensors can be operated with a higher bias voltage of 700 V, which means higher electric field and as a result, a higher charge collection distance. The Schottky type sensors biased with high voltage can potentially improve poor charge carriers transport properties typical for CdTe material due to the presence of defects and impurities in the crystals which act as trapping center [8].

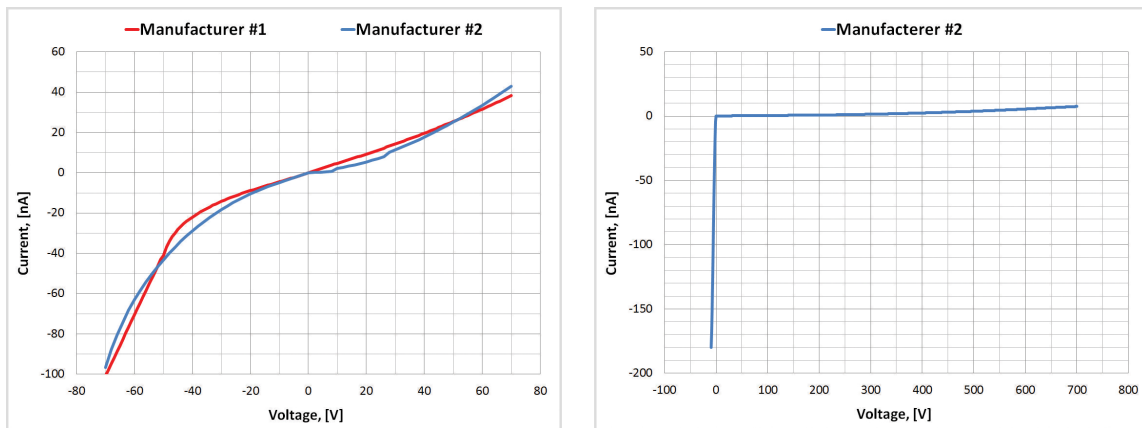


Figure 3: I-V curves of the CdTe Ohmic (left) and the Schottky (right) sensors.

Unlike the Si semiconductor detectors, where the capacitance depends on the depth of depleted zone, the capacitance of CdTe sensors is constant, because the active volume of the detector does not change with bias voltage. Fig.4 shows the C-V curves measured in the light-tight box at room temperature with 1 MHz frequency.

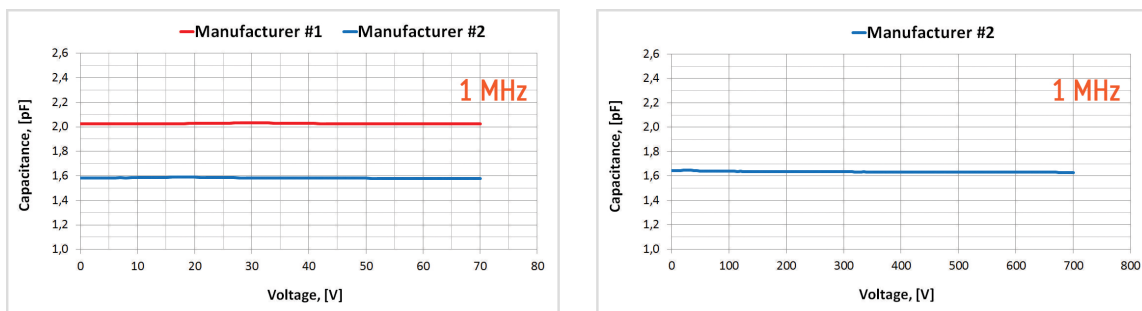


Figure 4: C-V curves of the CdTe Ohmic (left) and the Schottky (right) sensors.

3. I-V measurements as a function of temperature

The leakage current is a key parameter in characterising of spectrometric properties of the CdTe sensors, as the fluctuations of the leakage current are the most important source of noise

in CdTe sensors [2]. Fig.5 shows leakage current of the Ohmic type (left) and the Schottky type (right) sensors measured in the temperature range of $\langle -40, 40 \rangle^\circ\text{C}$. It can be seen that the leakage current of both sensor types decreases with the decrease of temperature. At the temperature of 40°C , the dark current of the Ohmic type sensor at the bias voltage of 70 V increased from 43 nA (at 20°C) to 145 nA, and for the Schottky type sensor at the bias of 700 V from 10 nA to 21 nA, but it still within acceptable range for spectrometric measurements. The values of the dark current of the Ohmic sensor type at 20°C (43 nA) and 0°C (6 nA) show, that cooling is a very effective way to decrease the leakage current and potentially improve spectrometry resolution of the CdTe sensors.

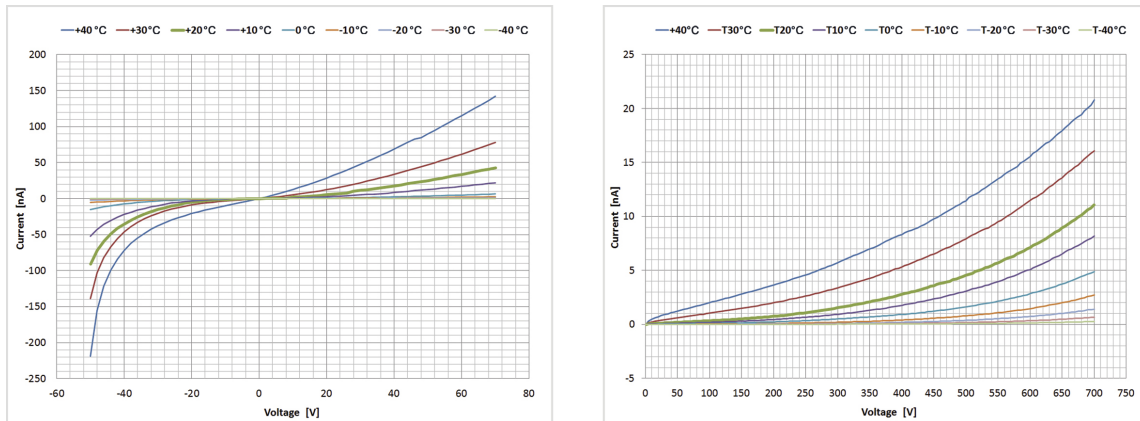


Figure 5: I-V curves of the CdTe Ohmic (left) and Schottky (right) sensors as a function of temperature. Manufacturer #2.

4. I-V measurements as a function of radiation dose

The main application of the CdTe detectors is gamma rays detection. To assess the performance of these detectors under irradiation, both sensor types were exposed to radiation from a ^{60}Co source, which emits photons with the energy of 1.17 MeV and 1.33 MeV. The total dose was 100 kGy with a step of 10 kGy. The I-V characteristics were measured after each step at room temperature in the light-tight box. During irradiation, the temperature was kept constant at 24°C . The time period between irradiation steps were about 30 minutes to make the I-V measurements.

Fig.6 shows the I-V curves of Ohmic type sensors. After the first radiation step, 10 kGy, the dark current of sensors from both manufacturers decreased significantly from 43 nA to 10 nA at the bias voltage of 70V. Then up to dose of 50 kGy, resistance was kept roughly constant. For the absorbed dose in the range from 50 kGy up to 100 kGy the dark current increased to 50 nA for positive bias voltage of 70 V. For the negative bias voltage, both Ohmic type sensors had constant resistance from 10 kGy up to 70 kGy. Then dark current of Ohmic sensor purchased from manufacturer #1 for the absorbed dose from 70 kGy to 100 kGy increased from 10 nA to 18 nA at the bias voltage of -70 V, which is still lower than the dark current of an unirradiated sample. However, in the case of the Ohmic sensor from manufacturer #2, the dark current after radiation dose of 90 kGy at the bias of voltage of -70 V was very large, and this sensor could not be operated with negative bias voltage of -70 V after radiation dose 90 kGy.

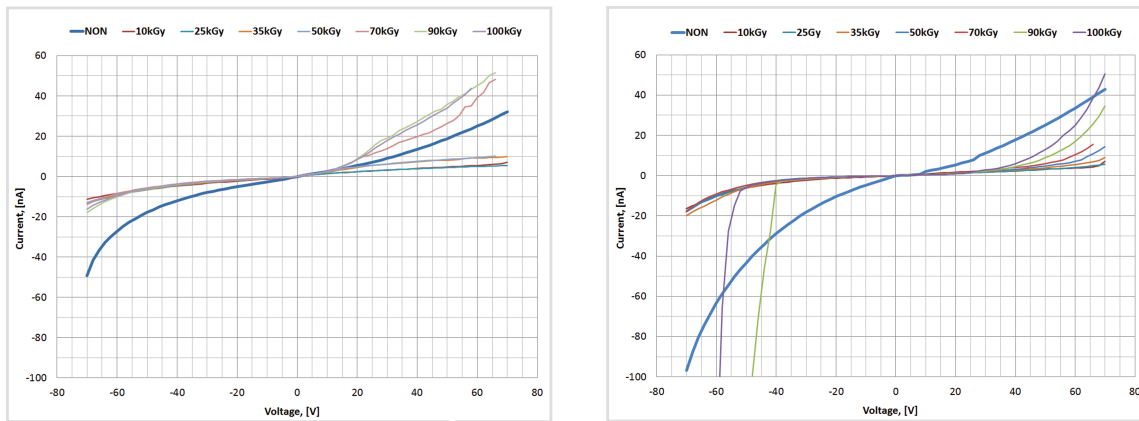


Figure 6: I-V curves of Ohmic type sensors from manufacturer #1 (left) and manufacturer #2 (right) as a function of radiation dose.

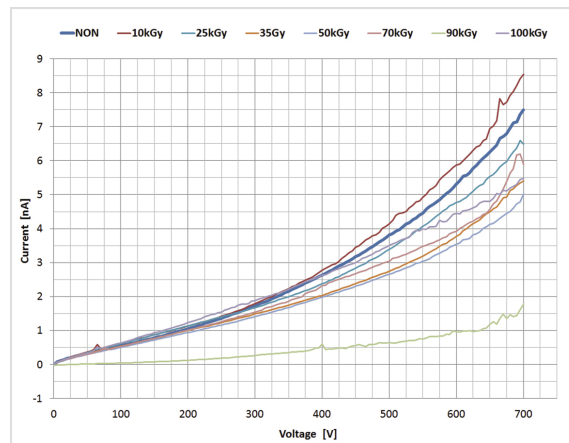


Figure 7: I-V curves of Schottky type sensor from manufacturer #2 as a function of radiation dose.

As can be seen in Fig.7, resistance of the Schottky sensor type from manufacturer #2 was not significantly affected by the ^{60}Co irradiation to the radiation dose of 100 kGy. The dark current was roughly constant during all measurements, it fluctuated from 2 nA to 8 nA at the bias voltage of 700 V.

The results of leakage current measurements after gamma-ray irradiation differ from the results of the similar measurements since year 2000 [1], where after irradiation to the dose of 50 kGy the leakage current of the sensor becomes almost 40 times bigger in comparison with the leakage current of the unirradiated sample at 70V, while in our case the leakage current after irradiation up to the dose of 50 kGy is 3 times smaller in comparison with unirradiated sensor (Ohmic type sensor).

Moreover, the most interesting effect is that after low dose (10 kGy) of gamma-ray irradiation the leakage current decreased significantly for the Ohmic type sensors from both manufacturers, which can be explained by the reduction of the charge carrier lifetime of the bulk [1].

5. Conclusions

The basic characteristics of the currently (May 2014) commercially available CdTe sensors were investigated to assess their potential performance in modern medical imaging. The studied CdTe sensors were purchased from two different manufacturers. Two types of sensors differing by the contact electrodes have been tested: sensor with ohmic and with rectifying (Schottky) contacts.

The leakage current as most important source of noise in the CdTe sensors [2] was studied as a function of bias voltage in the temperature range of $(-40, 40)^\circ\text{C}$. Additionally, I-V measurements after irradiation by ^{60}Co gamma-ray source to the radiation dose of 100 kGy were performed at room temperature. Major conclusions of the measurements can be drawn as follows:

- Both sensor types from two manufacturers show good performance in the temperature range of $(-40, 40)^\circ\text{C}$. The leakage current is within acceptable range for spectrometric measurements under these conditions.
- After low dose (10 kGy) of gamma-ray irradiation the leakage current decreased significantly for Ohmic type sensors from both manufacturers, while leakage current of the Schottky type sensor was almost unaffected.
- Schottky type sensor show more stable response with increasing dose than the Ohmic type sensor in terms of leakage current.
- Leakage current of the CdTe sensors operated with positive bias voltage after irradiation by gamma-ray source ^{60}Co to the radiation dose of 100 kGy increased for all tested samples but it is still within acceptable range for spectrometric measurements.
- The radiation hardness of the currently (May 2014) commercially available CdTe sensors is better in comparison with the sensors characterized with the similar measurements since year 2000 [1] in terms of leakage current.

6. Acknowledgement

We acknowledge the support of the European Commission within the Framework Programme 7 Capacities, Grant Agreement 262025 and by the Ministry of Education, Youth and Sports of the Czech Republic under the project Nr. 7E12050.

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